



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2823  
#3/ABW/JAN  
Appal  
11/28/02

Application Number 09/681,894  
Filing Date 6/21/01  
First Named Inventor Joseph R. Chavez  
Title Process for improving the radiation hardness of micro circuits  
Group Art Unit \_\_\_\_\_  
Examiner Name \_\_\_\_\_  
Attorney Docket No. PRS075

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

ASSOCIATE POWER OF ATTORNEY

The undersigned, having been appointed attorney in the above-identified application for a United States patent, hereby appoints James M. Skorich, Registration No. 27594 as my associate with full power to prosecute said application, to make alterations and amendments therein, and to transact all business in the Patent Office connected therewith.

All correspondence respecting the aforesaid application should be conducted with my above-named associate attorney at the address of record, namely:

RECEIVED  
U.S. PATENT AND TRADEMARK OFFICE  
C 2000 MAIL ROOM

377 ABW/JAN  
2251 Maxwell SE  
Kirtland AFB, NM 87117

Respectfully submitted,

Kenneth E. Callahan  
Attorney for Applicant(s)  
Registration No. 36763  
November 28, 2001